

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Wang

Application No.: 10/723,746

Filed: 11/25/2003

Title: POLISHING COMPOSITION FOR CMP
HAVING ABRASIVE PARTICLES

Attorney Docket No.: 03049US

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450Art Unit:
1765Examiner:
L. Umez EroniniRECEIVED
CENTRAL FAX CENTER
MAR 22 2006RESPONSE

Dear Sir:

In response to the Office Action of December 22, 2005, having a shortened statutory
deadline of March 22, 2006, please amend this application as follows:

Do Not Enter
Amendment
L. J. M-E
3/25/2006